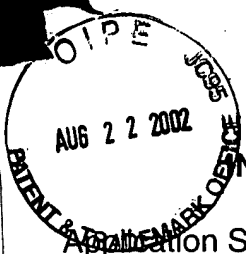


#11

EV077335093US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/909,111
Filing Date July 18, 2001
Inventor Mark Fischer
Assignee Micron Technology, Inc.
Group Art Unit 1765
Examiner Duy Deo
Attorney's Docket No. MI22-1777
Title: Semiconductor Processing Methods of Forming a Conductive Projection
and Methods of Increasing Alignment Tolerances

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

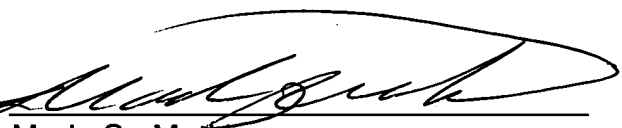
References - See Attached Form PTO-1449

The Examiner's attention is directed to the reference which is listed on the attached Form PTO-1449, a copy of which is attached. No admission is made regarding whether the submitted reference is prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 8/21/02

By: 
Mark S. Matkin
Reg. No. 32,268

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